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PATENT  
Attorney Docket No. 1110/98318

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application  
Applicant: Tetsuhiro IIDA et al.  
International Serial No.: PCT/JP2005/006321  
International Filing Date: March 31, 2005  
For: **SEMICONDUCTOR SINGLE CRYSTAL  
MANUFACTURING APPARATUS AND  
GRAPHITE CRUCIBLE**  
Examiner:

## Art Unit:

## INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313

Dear Sir:

Pursuant to 37 C.F.R. §1.97, a list of documents is disclosed on the attached Form PTO-1449 that may be material to the examination of this application. A copy of the International Search Report with cited references is enclosed.

No inferences should be drawn that the attached list represents a comprehensive investigation, or that any material disclosed is equivalent to the subject invention. In addition, none of the documents that have publication dates prior to the priority date of the above application anticipate the invention in this application.

The cited document(s) disclose numerous specific features. There has been no attempt to list each and every feature disclosed by each document. The Examiner is requested to review the document(s) and determine the extent of the materiality of the document disclosures with respect to the present invention.

The discussion of any art and the citation of any document(s) herein is not to be construed as an admission that the art or document disclosure is necessarily within the invention field of endeavor, that the art or document disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that the art or document disclosure is otherwise necessarily prior art as defined by the patent law with respect to the instant invention and application.

Also, there is reserved the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and document(s) recited herein, that may be cited by the Examiner in rejecting a claim in the instant patent application. The recitation herein of the art and document(s) is not to be construed as an assertion that more pertinent art could not possibly be in existence.

Respectfully submitted,  
**WELSH & KATZ, LTD.**



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Dated: September 26, 2006  
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>		Application Number	PCT/JP2005/006321
		Filing Date	March 31, 2005
		First Named Inventor	Tetsuhiro IIDA et al.
		Art Unit	
		Examiner Name	
Sheet	1	of	1
		Attorney Docket Number	1110/98318

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	MM-DD-YYYY			
	1	JP 2001-270797	10-02-2001	WACKER NSCE CORP		
	2	JP 2001-039792	02-13-2001	MITSUBISHI MATERIALS SILICON CORP		
	3	JP 09-263484	10-07-1997	SUMITOMO SITIX CORP		
	4	JP 02-217388	08-30-1990	OSAKA TITANIUM LO LTD, KYUSHU ELECTRON METAL CO LTD.		
	5	JP 05-070276	03-23-1993	SUMITOMO ELECTRIC IND LTD		
	6	JP 62-153191	07-08-1987	MITSUBISHI METAL CORP, NIPPON SILICON KK		

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T6

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